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EXPEDITED PROCEDURE . ART UNIT 1765

PATENT Attorney Docket No. 29936/39457

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:) I hereby certify that this paper and all documents referred to herein as being	
Hyung Jun Kim) enclosed are being transmitted to the United States Patent and Trademark	*
Serial No. 10/616,198) Office, via facsimile to:). Mail Stop AF	1001:00
Filed: July 9, 2003) facsimile number (571) 273-8300:	A De San
For: Method of Detecting a Polishing End Point in a Chemical Mechanical) December 30, 2005	,
Polishing Process	}	
Group Art Unit: 1765	1 9	3
Examiner: L.T. Umez-Bronini) James P. Zelfer, Reg. No. 28,491) Attorney for Applicant	- Ento

AMENDMENT "B" AFTER FINAL REJECTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is in response to the final official action dated October 31, 2005.

The Amendments to the Claim section (including a complete listing of claims) begins on page 2 of this paper.

The Remarks section begins on page 3 of this paper.

Do Not Enten

-Amendment.

- 1/4/2006